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PATENT 005018USA 7828.7056

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

دaminer: ۱	W. David	Colemar
(aminer:	aminer: W. David

Tepman, et al.

Serial No.: 10/074,854) Art Unit: 2823

Filed: February 11, 2002

For: VARIABLE FLOW DEPOSITION APPARATUS AND METHOD IN

SEMICONDUCTOR SUBSTRATE PROCESSING

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the office action mailed September 22, 2003 in the above-identified application. The requested period of extension is one month, from December 22, 2003 to January 22, 2004.

A check in the amount of \$110 to cover the extension fee is enclosed. The Commissioner is authorized to charge any additional fees which may be required, or to credit any overpayment, to Deposit Account 50-0585. A copy of this letter is enclosed.

Respectfully submitted,

William K. Konrad, Reg. No. 28,868

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail on the date/indicated above and is/addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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